

Emage

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

OKU et al

Serial No.: 09/903,764

Filed: July 13, 2001

For: FILM FORMING METHOD,  
SEMICONDUCTOR DEVICE AND  
SEMICONDUCTOR DEVICE  
MANUFACTURING METHOD



)  
) Examiner: K. Nguyen

)  
) Art Unit: 2823

SUPPLEMENTAL RESPONSE TO OFFICE ACTION OF DECEMBER 23, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Supplemental to applicants' response filed March 23, 2004, please amend the captioned application as follows: